IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): KATSUMATA et al.

Atty. Dkt.: 01-570

Serial No.: Unknown

Group Art Unit:

Filed: Concurrently herewith

Examiner:

Title: METHOD OF MANUFACTURING

SEMICONDUCTOR PRESSURE

SENSOR

Date: March 4, 2004

Commissioner for Patents Arlington, VA 22202

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §1.56, the reference(s) listed on the attached Form PTO-1449 is/are submitted for consideration by the Examiner without any admission that it/they constitute(s) statutory prior art, or without any admission that it/they contain(s) subject matter that anticipates the invention or renders the invention obvious to a person of ordinary skill in the art.

The Examiner is requested to initial the attached PTO Form-1449 and to return a copy of same to the undersigned attorney as proof that the listed reference(s) has/have been considered and made of record.

Respectfully submitted,

David G. Posz Reg. No. 37,701

Posz & Bethards, PLC 11250 Roger Bacon Drive, Suite 10 Reston, VA 20190

(703)707-9110 (phone)

Customer No. 23400

* PATENT APPLICATION

Page 1 of 1

FORM PTO-1449	ATTY. DKT NO.	01-570	SER. NO.	
	APPLICANT	KATSUMATA et		
	FILING DATE	March 4, 2004	GROUP	

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
	6,601,452 (English counterpart of JP-A-2001-356061 which is discussed in page 1)	Aug. 5, 2003	Murata et al.			
	6,595,065 (English counterpart of JP-A-H11-94666 which is discussed in pages 2)	Jul. 22, 2003	Tanizawa et al.			

FOREIGN PATENT DOCUMENTS

TRANSLATION

_		TRANSLATIC					11011			
		DOCUMENT NUMBER	DATE	COUNTRY	NAME	CLASS	SUB CLASS	YES	NO	
										Eng. Abstract
		JP-A-H01-261872	10/18/89	JAPAN						Х
	_	JP-A-H09-18016	1/17/97	JAPAN						X
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* Full English text is available in machine-translated form in JPO (Japanese Patent Office) English language web site at http://www1.ipdl.jpo.go.jp/PA1/cgi-bin/PA1INDEX.

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER	DATE CONSIDERED	

Rev. 10/94 (Form 3.05)